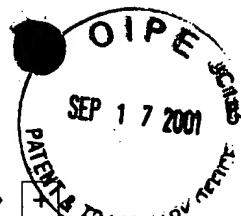


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PTO/SB/21 (08-00)

Approved for use through 10/31/02. OMB 0651-0031

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Application Number

09/557,961

Filing Date

April 25, 2001

First Named Inventor

Kunihiro TAKATANI

Group Art Unit

2811

Examiner Name

Donghee Kang

TECHNOLOGY REC'D

REC'D 20 SEP 2001

Attorney Docket No.

245402001600

ENCLOSURES (check all that apply)

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(for an Application) | <input type="checkbox"/> After Allowance Communication to Group |
| <input type="checkbox"/> Fee Attached | <input type="checkbox"/> Drawing(s) | <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences |
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under 37 CFR 1.52 or 1.53 | | |

SIGNATURE OF APPLICANT, ATTORNEY OR AGENT

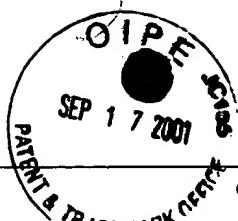
Firm or Individual Name	Jonathan Bockman Registration No. 45,640 Morrison & Foerster LLP 2000 Pennsylvania Avenue, N.W. Washington, D.C. 20006-1888 (202) 778-1601
Signature	
Date	September 17, 2001

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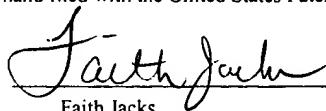
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Faith Jacks

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Kunihiro TAKATANI

Serial No.: 09/557,961

Filing Date: April 25, 2000

For: ELECTRODE STRUCTURE ON P-TYPE III GROUP NITRIDE SEMICONDUCTOR LAYER AND FORMATION METHOD THEREOF

Examiner: Donghee Kang

Group Art Unit: 2811

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AMENDMENT UNDER 37 CFR 1.111

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated June 15, 2001, please amend this application as follows:

AMENDMENTS

In the Claims:

Subt B' Please amend claim 1 as follows:

1. (Amended) An electrode structure on a p-type III group nitride semiconductor layer, comprising first, second and third electrode layers successively stacked on said semiconductor layer,